

<b>Notice of References Cited</b>	Application/Control No. 10/694,994	Applicant(s)/Patent Under Reexamination OKUWAKI ET AL.	
	Examiner Anabel M. Ton	Art Unit 2875	Page 1 of 1

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	C	US-4,373,282	02-1983	Wragg, Robert	40/546
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	L	US-			
	M	US-			

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**NON-PATENT DOCUMENTS**

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